

Appl. No.

10/695,379

: Confirmation No.:

5297

**Applicant** 

Manchao Xiao et al.

Filed

October 27, 2003

For

PRECURSORS FOR DEPOSITING SILICON CONTAINING FILMS

AND PROCESSES THEREOF

Art Unit

1762

Examiner

B. Chen

Docket No.

06377ZP

Customer No.

23543

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF MAILING

CERTIFY THAT THIS PAPER (ALONG WITH ANY PAPER REFERRED TO AS BEING ATTACHED OR ENCLOSED) IS BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE WITH SUFFICIENT POSTAGE AS FIRST CLASS MAIL IN AN **ENVELOPE ADDRESSED TO:** 

COMMISSIONER FOR PATENTS P.O. BOX 1450 ALEXANDRIA, VA 22313-1450

2006

Joseph D. Rossi

(Type or print name of persop mailing paper)

Signature of person mailing paper

REPLY PURSUANT TO 37 C.F.R. § 1.111

Sir:

The following is responsive to the Office Action dated November 16, 2005 ("the Action"):

A one (1) month extension of time is requested and authorization to charge the  $\square$ . Account of assignee is provided in an enclosed form.

Amendments to the Specification begin on page П

of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on X page 2 of this paper.

П Amendments to the Drawings begin on page of this paper and include an

attached replacement sheet(s).

Amendments to the Abstract are on page the Abstract is on page of this paper. of this paper. A clean version of

 $\boxtimes$ Remarks/Arguments begin on page 7 of this paper.